

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			
REQUEST FOR REFUND		Docket Number: 11403/84	
Application Number: 10/713,172	Filing Date: November 14,2003	Examiner: Francis P. Smith	Art Unit: 4151
Title: CRACK AND RESIDUE FREE CONFORMAL DEPOSITED SILICON OXIDE WITH PREDICTABLE AND UNIFORM ETCHING CHARACTERISTICS		Inventors: Aaron Partridge et al.	

Commissioner for Patents
P.O. Box 1450
Alexandra, VA 22313-1450

Sir:

On April 17, 2008 the Applicants electronically filed an Amendment for the above-captioned application. The attorney of record authorized the Commissioner to charge all fees to the Deposit Account of Kenyon & Kenyon LLP, deposit account number **11-0600**.

It is our understanding that the Commissioner charged the Deposit Account of the previous attorney of record, Deposit Account Number 50-0763. Accordingly, Applicants respectfully request that the extra claim fees of \$470.00 be credited back to the Deposit Account No. 50-0763 and that the extra claim fees of \$470.00 be charged to the deposit account of Kenyon & Kenyon LLP, deposit account number **11-0600**.

While no fees are believed to be due in connection with this Communication, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees or credit any overpayment to Deposit Account No. **11-0600**.

Respectfully submitted,

Date: June 17, 2008

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